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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.:	ATMI-337 RCE3
Applicant:)	Examiner:	HU, Shouxiang
Application No.:)	Confirmation No.:	4898
Date Filed:)	Art Unit:	2811
Title:)	Customer No.:	25559
OXIDATIVE TOP ELECTRODE DEPOSITION PROCESS, AND MICROELECTRONIC DEVICE STRUCTURE)		

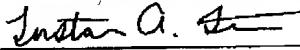
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ATTN: Examiner Hu
Fax No. (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 7, 2004 to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Tristan A. Fuierer

October 7, 2004

Date

**RESPONSE TO JULY 14, 2004 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 09/200,495**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the July 14, 2004 Office Action in the above-identified application.

2771-337 RCE3

Please amend the application as set out in the following **Section I** (Amendment of the Claims).

Remarks addressing the substance of the July 14, 2004 Office Action are set out in **Section II** (Remarks) hereof.